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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
Uzoh et al.

Serial No.: 10/698,878

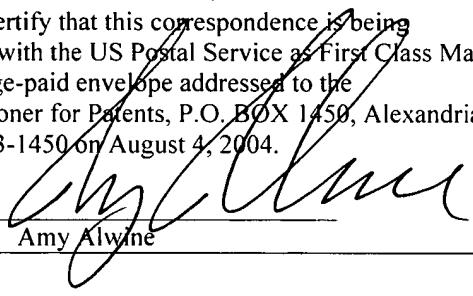
Filed: October 31, 2003

Title: Methods For Depositing High Yield And  
Low Defect Density Conductive Films In  
Damascene Structures

Group Art Unit: 2829  
Examiner: Not yet assigned  
Docket: NT-308-US

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
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Signed: 

Amy Alwine

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. BOX 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants submit information herewith to comply with the obligations set forth in 37 CFR §1.56. This submission is not an admission that any of the documents are prior art or otherwise relevant to the subject application.

This IDS is submitted:

- with a filed patent application or within 3 months of the US application filing date;
- before the mailing of a first office action on the merits;
- after the first office action, but prior to a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) or a certification set forth below; or
- after a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) and a certification set forth below, where this submission is a petition requesting consideration of this IDS.

If identified above, Applicant certifies that:

- the information was first cited in a communication from a foreign patent office in a counterpart foreign application less than 3 months prior to this IDS; or

[ ] to the knowledge of the person signing this certification after making reasonable inquiry, the information was not known to any individuals designated in 37 CFR §1.56 more than 3 months prior to this IDS.

If any matters can be resolved by telephone, Applicant requests that the Patent and Trademark Office call the Applicant at the telephone number listed below.

Respectfully submitted,

By:   
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**INFORMATION DISCLOSURE STATEMENT**

**US PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
		6,303,014	Oct., 2001	Taylor et al.	Copy Enclosed
		6,210,555	Apr., 2001	Taylor et al.	Copy Enclosed

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant		

**OTHER DOCUMENTS**

Examiner Initials	Cite No.			Trans-lation

Examiner Signature		Date Considered	
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